Holography, Diffractive Optics, and Applications XIV

Changhe Zhou Ting-Chung Poon Liangcai Cao Hiroshi Yoshikawa Editors

12–15 October 2024 Nantong, China

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Published by SPIE

Volume 13240

Proceedings of SPIE 0277-786X, V. 13240

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Holography, Diffractive Optics, and Applications XIV, edited by Changhe Zhou, Ting-Chung Poon, Liangcai Cao, Hiroshi Yoshikawa, Proc. of SPIE Vol. 13240, 1324001 © 2024 SPIE · 0277-786X · doi: 10.1117/12.3057344 The papers in this volume were part of the technical conference cited on the cover and title page. Papers were selected and subject to review by the editors and conference program committee. Some conference presentations may not be available for publication. Additional papers and presentation recordings may be available online in the SPIE Digital Library at SPIEDigitalLibrary.org.

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Please use the following format to cite material from these proceedings: Author(s), "Title of Paper," in *Holography, Diffractive Optics, and Applications XIV*, edited by Changhe Zhou, Ting-Chung Poon, Liangcai Cao, Hiroshi Yoshikawa, Proc. of SPIE 13240, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X ISSN: 1996-756X (electronic)

ISBN: 9781510682085 ISBN: 9781510682092 (electronic)

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